



OP 2822
14/Supp
PATENT IDS
0756-1838
Lewis
5/4/00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)
Shunpei YAMAZAKI, et al.) Group: 2822
Serial No.: 09/118,010) Examiner: M. Guerrero
Filed: July 17, 1998)
Title: SEMICONDUCTOR DEVICE,)
METHOD OF FABRICATING)
SAME AND ELECTROOPTICAL)
DEVICE)

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

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TECHNOLOGY CENTER 2800

Honorable Assistant Commissioner of Patents
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached PTO-1449 forms be made of record in the above-identified application. Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

This Information Disclosure Statement is being filed to supplement the IDS filed March 21, 2000, under 37 C.F.R. § 1.97(c)(2).

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 25 April 2000

Melissa M. McElroy



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The Commissioner his hereby authorized to charge fees under 37 C.F.R. §§ 1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380 (0756-2057). **A duplicate copy of this sheet is attached.**

Respectfully submitted,

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